

L Number	Hits	Search Text	DB	Time stamp
1	6	((("6280802") or ("6254928") or ("6097144") or ("6074888") or ("5958348") or ("5874134")).PN. ("5958348").PN.	USPAT; US-PGPUB	2001/10/12 12:07
-	1	("5958348").PN.	USPAT; US-PGPUB	2001/10/12 12:06
-	0	085514.an.	USPAT; US-PGPUB	2001/10/03 14:29
-	0	85514.an.	USPAT; US-PGPUB	2001/10/03 14:29
-	0	09/085514.an.	USPAT; US-PGPUB	2001/10/03 14:29
-	4	"085514"	USPAT; US-PGPUB	2001/10/03 15:34
-	95	("427/567").CCLS.	USPAT; US-PGPUB	2001/10/03 15:35
-	19	((("427/567").CCLS.) and laser	USPAT; US-PGPUB	2001/10/03 15:44
-	177	bi.in.	USPAT; US-PGPUB	2001/10/03 15:44
-	18	bi-xiangxin.in.	USPAT; US-PGPUB	2001/10/03 15:58
-	0	ractive adj deposition	USPAT; US-PGPUB	2001/10/03 15:59
-	364	reactive adj deposition	USPAT; US-PGPUB	2001/10/03 15:59
-	15	(reactive adj deposition) with laser	USPAT; US-PGPUB	2001/10/03 16:00
-	0	((reactive adj deposition) and laser) and	USPAT; US-PGPUB	2001/10/03 16:04
-	0	reactant adj stream	USPAT; US-PGPUB	2001/10/03 16:32
-	0	light adj reactive adj deposition	USPAT; US-PGPUB	2001/10/03 16:32
-	113	(reactive adj deposition) and laser	USPAT; US-PGPUB	2001/10/04 16:28
-	383	("427/475,477,479,480").CCLS.	USPAT; US-PGPUB	2001/10/05 11:29
-	106	("427/477").CCLS.	USPAT; US-PGPUB	2001/10/05 11:30
-	0	((("427/477").CCLS.) and glasss	USPAT; US-PGPUB	2001/10/05 11:30
-	19	((("427/477").CCLS.) and glass	USPAT; US-PGPUB	2001/10/05 11:30
-	2626	glass adj coating	USPAT; US-PGPUB	2001/10/05 12:17
-	0	(glass adj coating) and particles with	USPAT; US-PGPUB	2001/10/05 12:17
-	132	product adj stream	USPAT; US-PGPUB	2001/10/05 12:19
-	131	(glass adj coating) with particles	USPAT; US-PGPUB	2001/10/05 12:19
-	21	@ad<=20001017	USPAT; US-PGPUB	2001/10/05 14:09
-	95	electrostatic adj powder adj application	USPAT; US-PGPUB	2001/10/05 14:10
-	95	("427/567").CCLS.	USPAT; US-PGPUB	2001/10/05 14:10
-	95	((("427/567").CCLS.)	USPAT; US-PGPUB	2001/10/05 14:10
-	19	((("427/567").CCLS.) and laser	USPAT; US-PGPUB	2001/10/05 14:15
-	44	("427/568").CCLS.	USPAT; US-PGPUB	2001/10/05 14:15
-	1	((("427/568").CCLS.) and pyrolysis	USPAT; US-PGPUB	2001/10/05 14:15
-	70	laser adj pyrolysis	USPAT; US-PGPUB	2001/10/05 14:18
-	26	(laser adj pyrolysis) and substrate	USPAT; US-PGPUB	2001/10/10 11:40
-	16	nanogram adj corporation	USPAT; US-PGPUB	2001/10/05 14:41
-	3	(nanogram adj corporation) and	USPAT; US-PGPUB	2001/10/05 14:42
-		@pd<=19991017	USPAT; US-PGPUB	

-	1	("6290735").PN.	USPAT; US-PGPUB	2001/10/10 11:33
-	45	(laser adj pyrolysis) and coating	USPAT; US-PGPUB	2001/10/10 11:40
-	37	(laser adj pyrolysis) and coating and particle	USPAT; US-PGPUB	2001/10/10 11:41
-	1	"6290735"	USPAT; US-PGPUB	2001/10/10 11:58
-	1	("6025034").PN.	USPAT; US-PGPUB	2001/10/10 16:38
-	0	("particle with spraying with coat\$").PN.	USPAT; US-PGPUB	2001/10/10 16:38
-	1	particle with spraying with coat\$	USPAT; US-PGPUB	2001/10/10 16:39
-	2058	particle with spraying with coat\$	USPAT; US-PGPUB	2001/10/10 16:39
-	59	(particle with spraying with coat\$) and moving with substrate	USPAT; US-PGPUB	2001/10/10 16:39
-	16	(particle with spraying with coat\$) and moving with inlet	USPAT; US-PGPUB	2001/10/10 16:45
-	0	808850.an.	USPAT; US-PGPUB	2001/10/11 10:19
-	5	"808850"	USPAT; US-PGPUB	2001/10/11 10:19
-	21399	chamber with substrate	USPAT; US-PGPUB	2001/10/11 15:08
-	170	(chamber with substrate) with pump\$ with out	USPAT; US-PGPUB	2001/10/11 16:20
-	24047	photolithography	USPAT; US-PGPUB	2001/10/11 16:20
-	15	photolithography with optical adj components	USPAT; US-PGPUB	2001/10/11 16:21